CERTIFICATE OF HAND DELIVERY

I hereby certify that this correspondence is being hand filed with the United States Patent and Trademark Office in Washington, D.C. on

June 11, 2002

N. Slaveter

JUN 1 1 2002 88

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Kunihiro TAKATANI

Serial No.:

09/557,961

Filing Date:

April 25, 2000

For:

ELECTRODE STRUCTURE ON P-

TYPE III GROUP NITRIDE

SEMICONDUCTOR LAYER AND FORMATION METHOD THEREOF

Examiner: Donghee Kang

Group Art Unit: 2811

JUN 13 2002
TECHNOLOGY CENTER 2

AMENDMENT UNDER 37 CFR 1.116

Box AF

Commissioner for Patents Washington, D.C. 20231

Sir:

In response to the final Office Action dated February 13, 2002, please amend this application as follows:

AMENDMENTS

In the Claims:

Please amend claims 1 and 8 as follows:

1. (Twice Amended) An electrode structure on a p-type III group nitride

semiconductor layer, comprising first, second and third electrode layers successively stacked on

said semiconductor layer,